



PATENT
Attorney Docket No.: AUB-06300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yonhua Tzeng

Serial No.: 10/772,740

Filed: February 5, 2004

For: **METHOD OF PLASMA
ENHANCED CHEMICAL VAPOR
DEPOSITION OF DIAMOND
USING METHANOL-BASED
SOLUTIONS**

) Art Unit:2817

) Examiner: Stouffer, Kelly M.

) **REQUEST FOR A ONE MONTH
EXTENSION OF TIME**

) 162 North Wolfe Road
) Sunnyvale, CA 94086
) (408)530-9700

) Customer Number 28960

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby petition for a one month extension of time to answer the outstanding Office Action mailed May 12, 2008, regarding the above-identified patent application. Please find a check enclosed in the amount of \$465.00 which includes, the fee of \$405.00 for the request for continued examination plus \$60.00 to cover the extension of time within the first month.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: September 4, 2008

By: Jonathan O. Owens
Jonathan O. Owens
Reg. No.: 37,902

09/09/2008 HDESTA1 00000088 10772740

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Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR 1.8(a)) -
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Date: 9/4/08 By: [Signature]